

EXPEDITED PROCEDURE
Examining Group Number 4146

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Werner Ertle et al.	Examiner:	Robert T. Huber
Serial No.:	10/522,502	Group Art Unit:	4146
Filed:	November 11, 2005	Docket No.:	I431.124.101/FIN404PCT/US
Title:	SEMICONDUCTOR WAFER WITH ELECTRICALLY CONNECTED CONTACT AND TEST AREAS		

AMENDMENT AND RESPONSE UNDER 37 C.F.R. 1.116

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This Amendment and Response is in reply to the Final Office Action mailed November 10, 2009. Please amend the above-identified patent application as follows: